Docket No. 740756-1641

AUG 0 3 2004

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

|        | In re Patent Application of:   | )   |
|--------|--|---|
|        | Hongyong ZHANG et al.  | ) Group Art Unit: 2823                            |
| 2      | Application No. 08/811,742   | )   |
| Cl 1   | Filed: March 6, 1997   | ) Examiner: K. NGUYEN                             |
| wing ? | For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD OF THE SAME  CERTIFICATE OF MAILING OR  | ) Confirmation No.: 1505                          |
| # #    | I hereby certify that this correspondence is being:  |   |
|        | deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 |   |
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| D b    | Date   | Signature Kisha L. Avery                          |
| •      |  | Typed or printed name                             |

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT AFTER FINAL OFFICE ACTION

Sir:

The following is presented in response to the Office Action, mailed April 29, 2004, in connection with the above-captioned patent application.